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Application/Control No	rol No. Applicant(s)/Patent under Reexamination	
10/611,365	WANG ET AL	
Examiner	Art Unit	
Mellissa M. Chojnack	i 2164	

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SEARCH NOT (INCLUDING SEARCH)
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Searched EAST, USPTO, JPO, EPO, IBM_TDB, PGPUB, Strategy enclosed.	12/22/2006	MMC
Consulted Examiner Neveen-Abel-Jalil and Primary Examiner Sam Rimell regarding art and office action.	12/22/2006	ммс
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